

Docket No. 219723US-2S

IN RE APPLICATION OF: Hajime AGANO ET AL.

SERIAL NO: 10/078,344

FILED: FEBRUARY 21, 2002

FOR: SEMICONDUCTOR DEVICE USING PARTIAL SOI SUBSTRATE AND MANUFACTURING METHOD THEREOF

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	8	MINUS	25	0	x \$18 =	\$0.00
INDEPENDENT	1	MINUS	3	0	x \$84 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

☐ A check in the amount of \$0.00 is attached.

☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.



22850

Customer Number 22850
Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 05/03)

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

David Bilodeau

Eckhard H. Kuesters

Registration No. 28,870

David A. Bilodeau

Registration No. 42,325

RECEIVED
JUN - 1 2003
TECHNOLOGY CENTER 2800

Application No. 10/078,344
Reply to Office Action of March 28, 2003

11/Amdt A
7/7/03
C. Pci

DOCKET NO: 219723US-2S



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HAJIME NAGANO ET AL. : EXAMINER: NGO, N.
SERIAL NO: 10/078,344 :
FILED: FEBRUARY 21, 2002 : GROUP ART UNIT: 2814
FOR: SEMICONDUCTOR DEVICE
USING PARTIAL SOI SUBSTRATE AND
MANUFACTURING METHOD THEREOF

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated March 28, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

Remarks/Arguments begin on page 7 of this paper.

RECEIVED
JUN - 1 2003
TECHNOLOGY CENTER 2800